

Resistive MPGDs

Screen printed resistors versus DLC

Rui De Oliveira

workshop on the upgrade of T2K March 20-21

- MM Projects @ CERN and MPGD R&D
- Medium rates detectors
- High rate detectors
- Screen printed resistor Spark study
- conclusion

Resistive MPGD projects at CERN

•Production of MM

- ATLAS NSW
- CLAS 12
- Mcube
- Gbar
- LSBB
- BL4S
- STD detectors 10 x 10 1D
- STD detectors 10 x 10 2D

resistor family
screen printed
screen printed
screen printed
screen printed
DLC
gap filling
screen printed
gap filling

•R&D Micromegas

- ATLAS resistive Kapton Micromegas Muon large pitch
- ATLAS High rate screen printed Embedded resistors BULK
- High rate DLC Embedded BULK Micromegas detector
- Embedded front end electronics in read-out boards
- Micromegas pS resistif
- Transparent Micromegas detectors

resistive Kapton
screen printed
DLC
Screen printed
Screen printed
ITO

•R&D other resistive structures

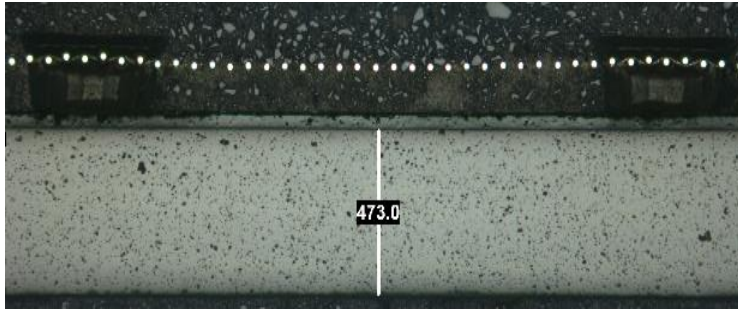
- CMS FTM multiple resistive well detectors
- CMS u-Rwell high rate Muon detectors
- LHCB u-Rwell high rate Muon detectors
- Low cost sticky Piggy back u-Rwell

DLC
DLC
DLC
DLC

BULK or Standard ?

"bulk" Micromegas

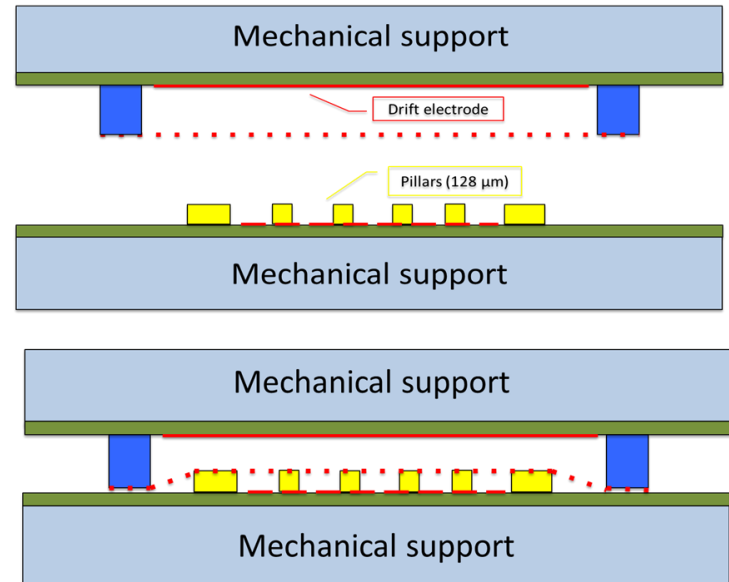
Mesh embedded in pillars



- Production in clean room is mandatory to avoid dust trapping
- We are now at CERN artificially limiting the size to 550mm x 550mm active area for optimum yield
- Self supporting , limited dead zones
- Cylindrical detectors

"Standard" Micromegas

Mesh separated from pillars

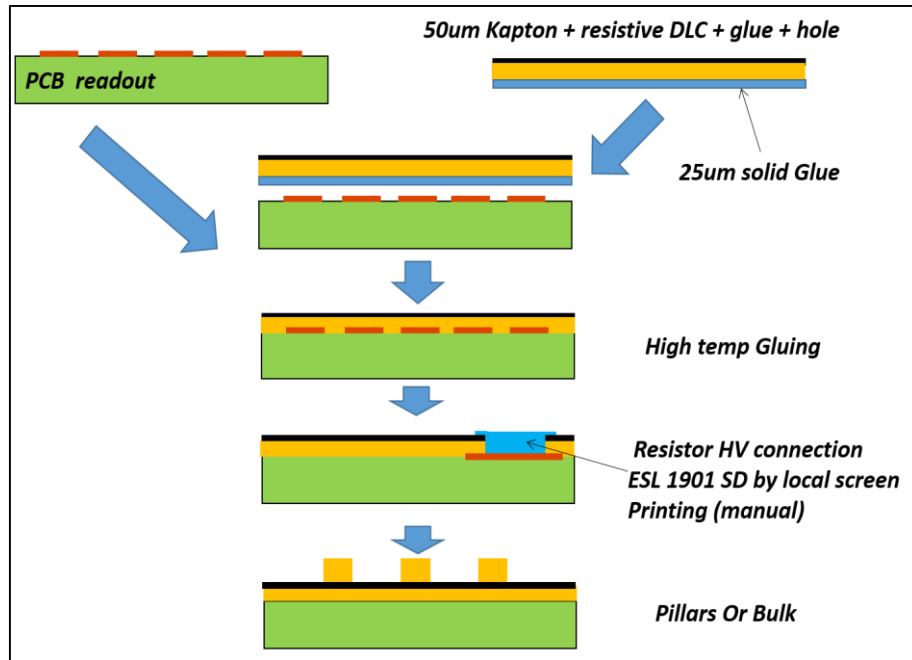


- Need strong mechanical supports
- Planarity to be controlled! (to guarantee amplification gap constant)
- Large sizes (~ 2m) (ATLAS)
- easy to open and clean
- Lower cost for mass production

- Medium rate detectors
0 to 100kHz/cm²

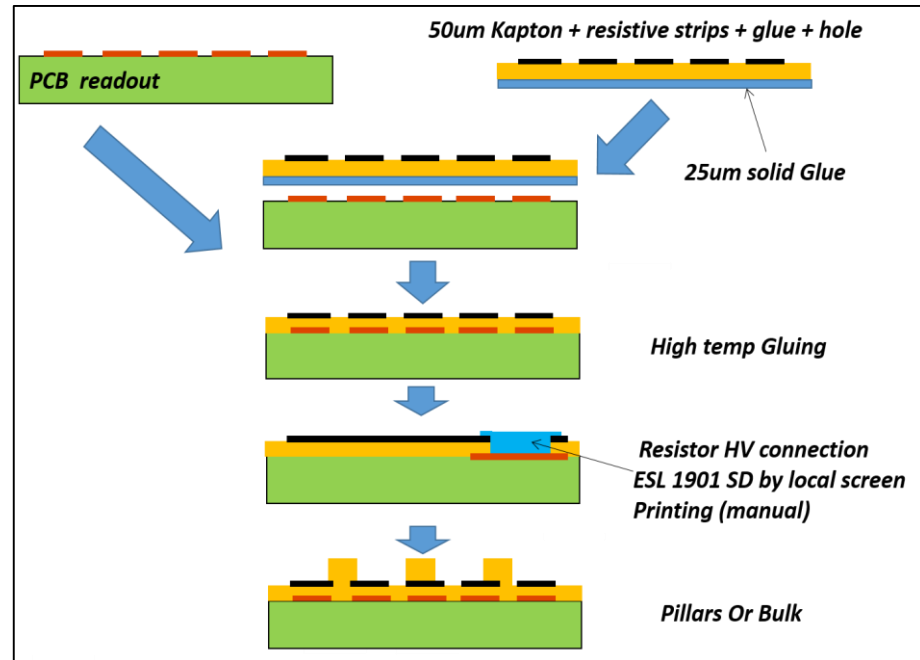
Resistor scheme in Micromegas detectors for medium rates

DLC



- Single source today
- DLC size limited now to 1.2m x 0.6m max
- No tooling
- less charging up due to inter-pads dielectric
- 1Mohms/square up to 1Gohms/square
- Clusters are equal in X/Y read-out

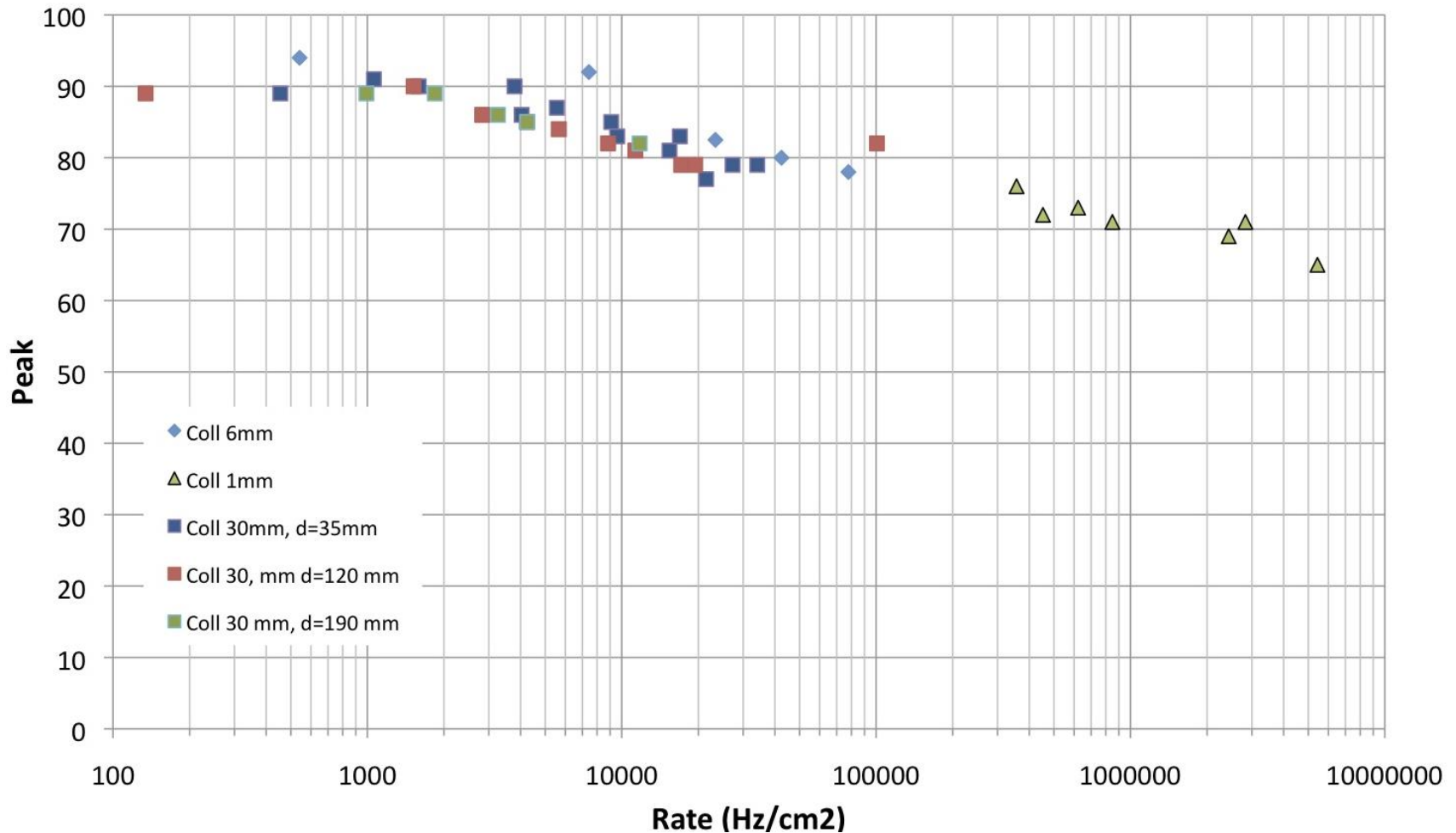
Screen printing



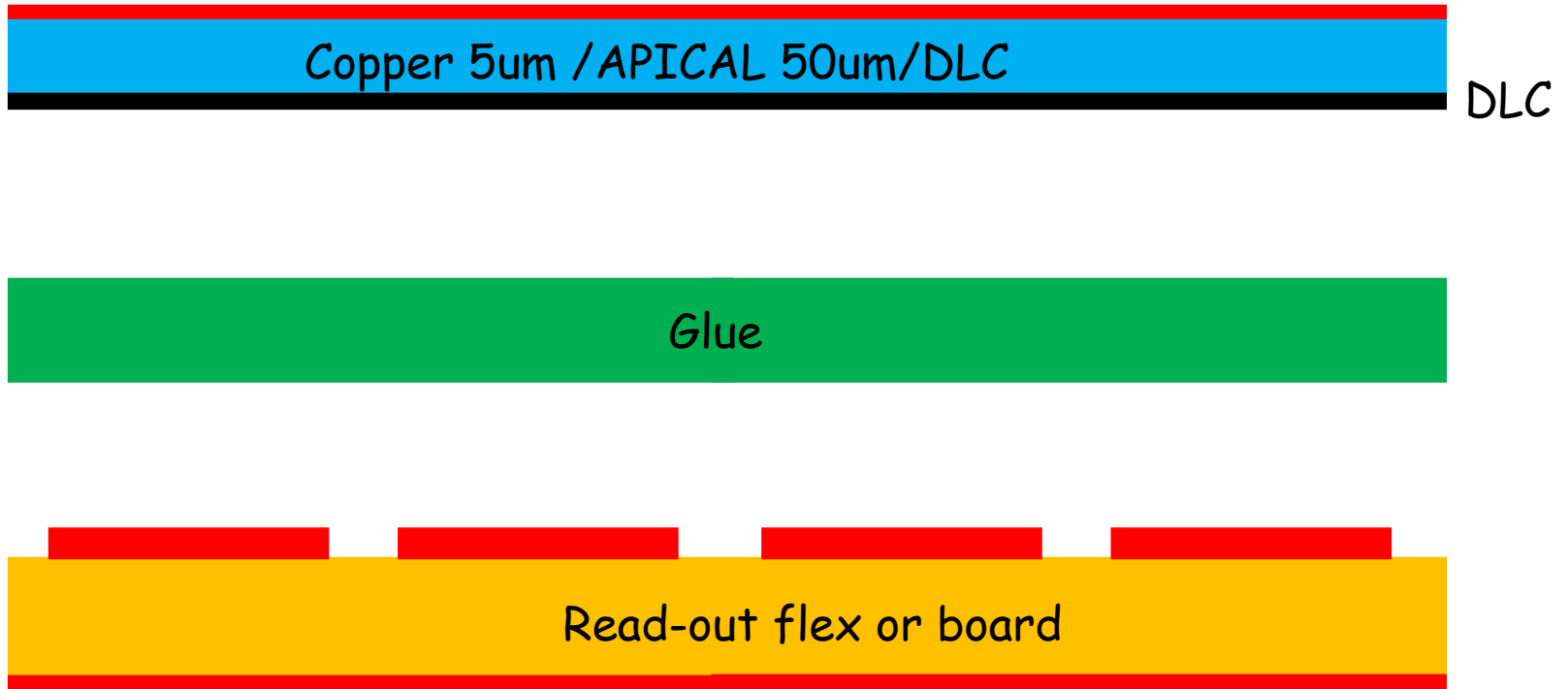
- Need tooling for screen printing
- Need alignment
- 1K ohms /square up to 100Kohms/square
- Different clusters in X/Y read-out
- Low cost in large volume
- Routine Screen printing up to 2m x 0.5m
- Many suppliers are existing

R11-rate performance

R11 -- Cu x-ray Peak vs Rate (560 V, 8 keV Cu x-ray, Ar:CO₂ 85:15)



u-Rwell for medium rate



u-Rwell medium rate



Vacuum Press gluing

u-Rwell medium rate



Top copper pattern + APICAL etch
Detector ready

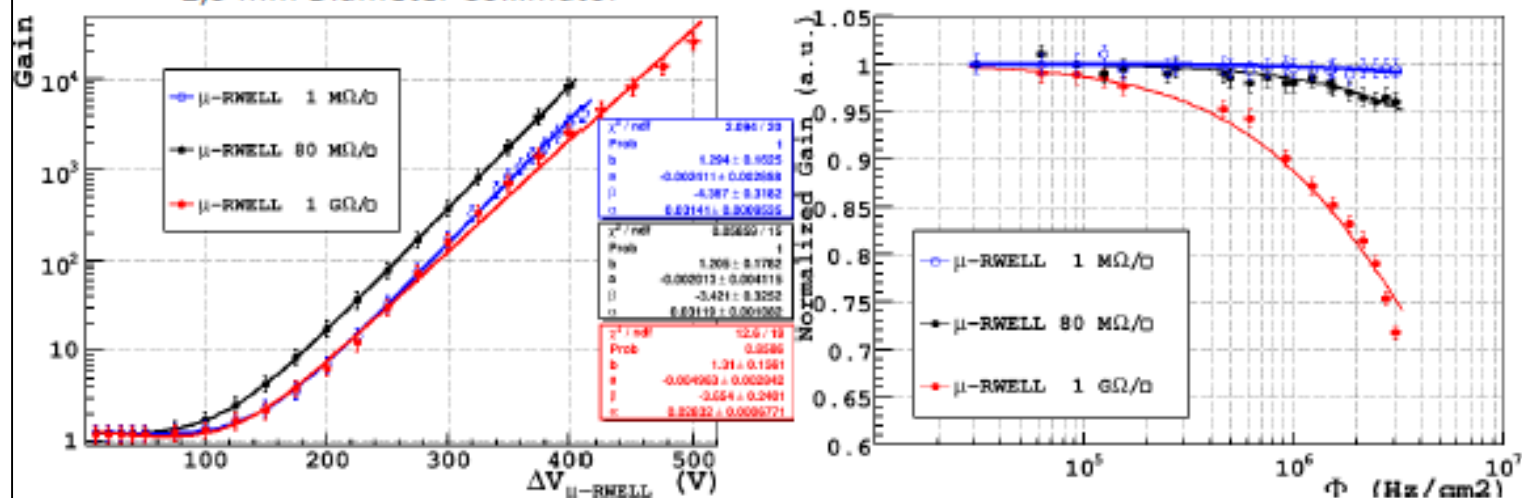
Flexible or rigid detector
Radio pure materials possible
thickness of 0.2mm possible

Max size today : 1.2m x 0.55m
Real limit 1.6m x 0.55m
Cheapest MPGD detector

μ -RWELL: other prototypes

X-ray tube, Ar: i C₄H₁₀ 90:10

2,5 mm Diameter Collimator



Fit Results:

Resistivity declared by the deliverer: 1 G Ω/\square ; from fit $\rho_s = 883.8 \pm 176.7$ M Ω/\square

Resistivity declared by the deliverer: 80 M Ω/\square ; from fit $\rho_s = 79.3 \pm 15.8$ M Ω/\square

Resistivity declared by the deliverer: 1 M Ω/\square ; from fit $\rho_s = 11.7 \pm 2.3$ M Ω/\square

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Giovanni Bencivenni and all 2016

- High rate detectors
From 100Khz to "100Mhz/cm²"

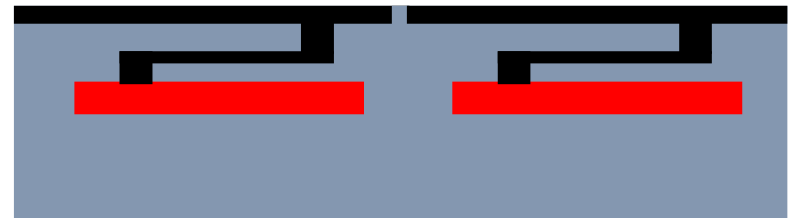
Embedded resistors are mandatory for High rate applications

- The embedded resistor evacuates locally the charges
- We can define the embedded resistor max spark power and its breakdown voltage by design

Surface resistor



2 layers



- The thickness above the pad should be limited in both structures
- Around 50 to 75um on the produced prototypes

MM Production steps



Bare PCB

MM Production steps



Bare PCB



Coverlay gluing + via fill

MM Production steps



Bare PCB



Coverlay gluing + via fill



Inner resistor printing

MM Production steps



Bare PCB



Coverlay gluing + via fill



Inner resistor printing



Coverlay gluing + via fill
+top resistive layer print

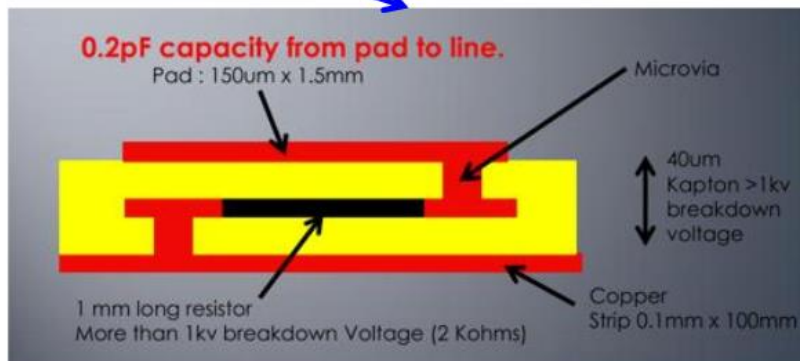
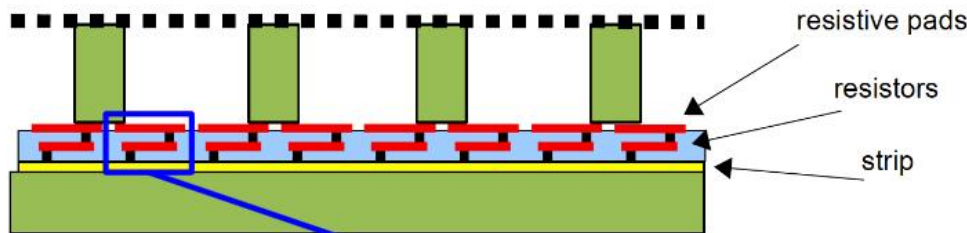
Ready for BULK process

MM with embedded resistors : High rate

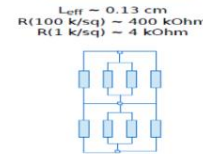
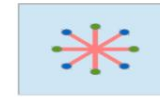
Shapes and values

Mr Chefdeville R1 Detectors for the LAPP

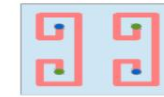
- Quick rise of the resistive pads' potential
- Limitation of the discharge amplitude
- **Compatible with a pixelized readout**



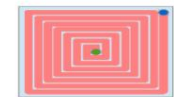
Design by Rui de Oliveira et al.



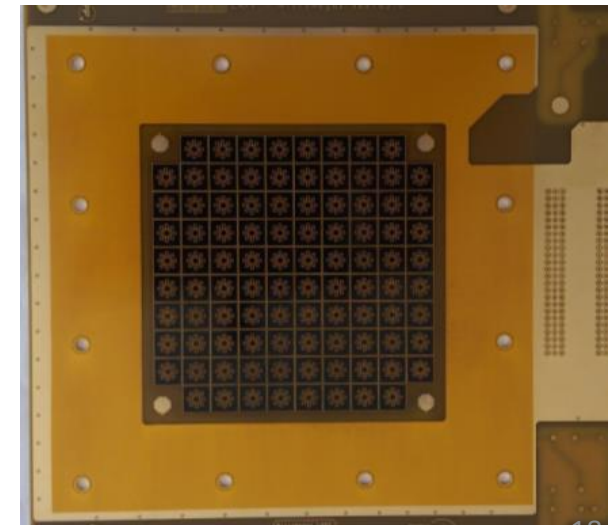
Real values:
40 to 60 KOhms with 10KΩ/Sq
400 to 750 KOhms With 100KΩ/Sq



Real values:
400 KOhms with 10KΩ/Sq
4 MOhms With 100Ω/Sq



Real values:
4 MOhms with 10KΩ/Sq
40 MOhms With 100Ω/Sq



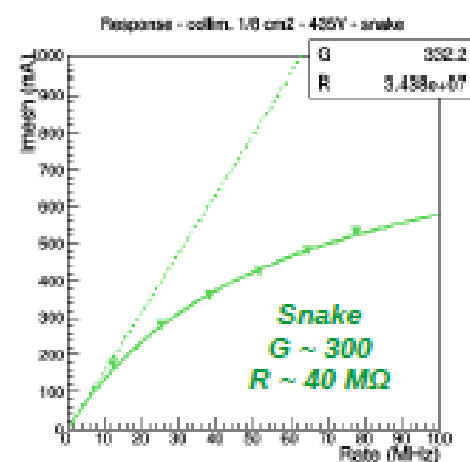
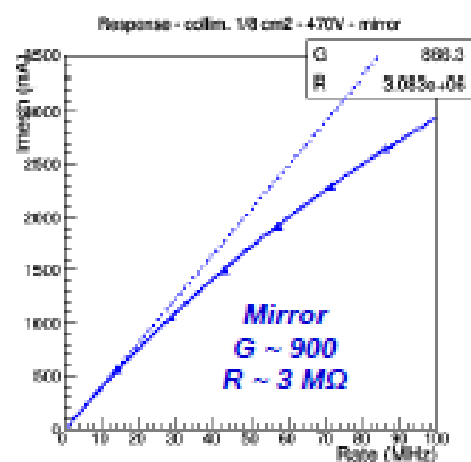
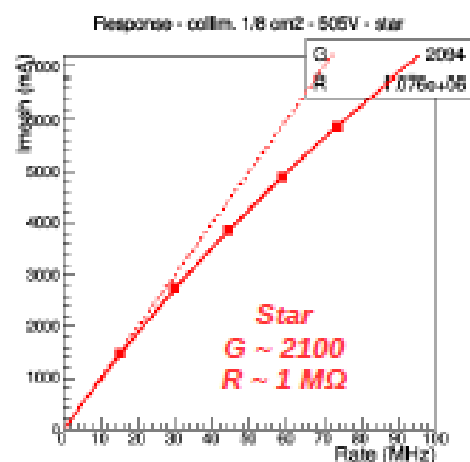
Rate capability

Here : linearity deviations less than 1 % at $G = 4200$, for 8 keV Xrays & 1 MHz/mm²
 Can be extrapolated to other running conditions (better for MIPs, worse for showers)
 Anyway, 1 MHz/mm² remains impressive.

Response curves (current I VS rate f) are described by : $I(f) \sim Q_0 \cdot f / (1 + B \cdot R \cdot Q_0 \cdot f)$
 $[B] = 1/V$, slope of gain curve ; $Q_0 = q_e \cdot N_p \cdot G_0$, primary charge * $G(dV=0)$

→ (G_0, R) are fitted to the data.

Useful for characterisation.



Max Chefdeville and all Lapp dec 2015

u-Rwell Process for high rate



A cross-sectional diagram of a u-Rwell structure. It consists of a central blue layer labeled '5um copper/50um APICAL/DLC'. This layer is flanked by red layers on the top and bottom, and a black layer on the right. The entire structure is set against a white background.

5um copper/50um APICAL/DLC

DLC1

Base material , DLC (100 Mohms/square)

u-Rwell Process for high rate



Glue DLC2 (100M) layer (pre drilled) on DLC1(100M)
via filling with silver paste (yellow)

Screen printed resistors above 10K/square are not behaving correctly
in this multilayer configuration

u-Rwell Process for high rate



Glue a flex read-out circuit (Strip or pad) pre drilled (green) on DLC2
via filling with silver paste (yellow)

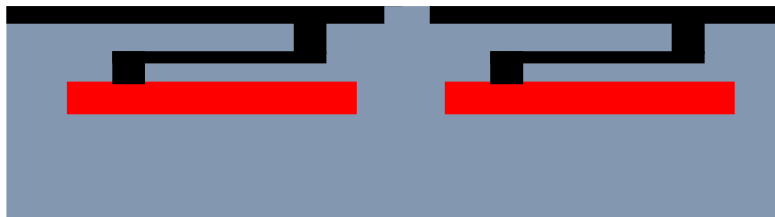
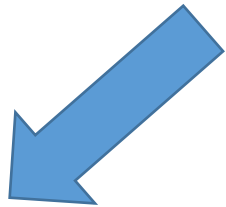
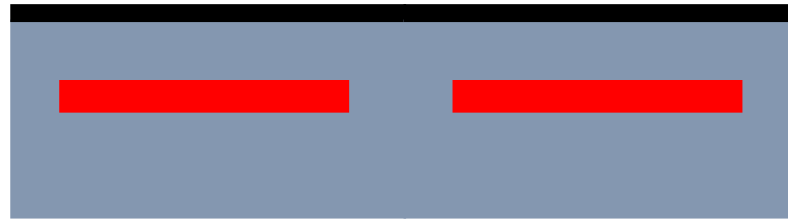
u-Rwell Process for high rate



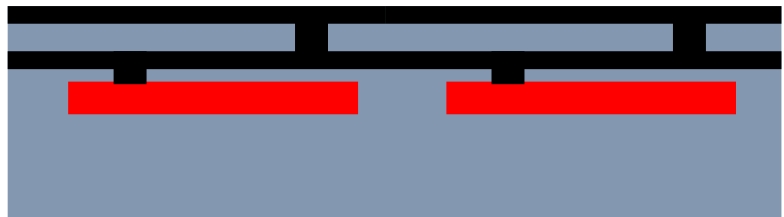
Top layer patterning
APICAL etching

- MM Resistive BULK with DLC?

Medium rates
Single layer protection
Screen printed or DLC



High rates
Digital read-out
2 layers screen printed



High rates
Analog read-out
2 layers DLC (R&D in progress)

Screen printing Vs DLC

Screen printing

- 10K to 100 K/square
- need a pattern
- X/Y clusters are different
- Medium cost
- no sharing
- Energy resolution
 - Similar to metallic MM
- Spark energy
 - 10^3 reduction / metallic MM

DLC

- 1M to 1G/square
- No pattern
- X/Y similar cluster
- Cheaper in low volumes
- Controlled sharing
- Energy resolution
 - Better than metallic MM (TBC)
- Spark energy
 - More than 10^3 reduction

- Screen printed resistor Spark study

SEM

observation

resistive

strips

after Spark

discharge

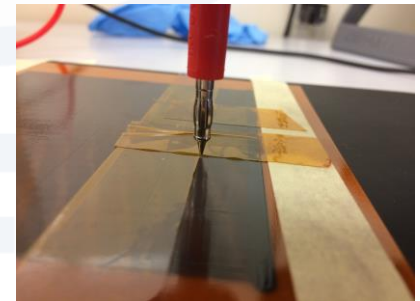
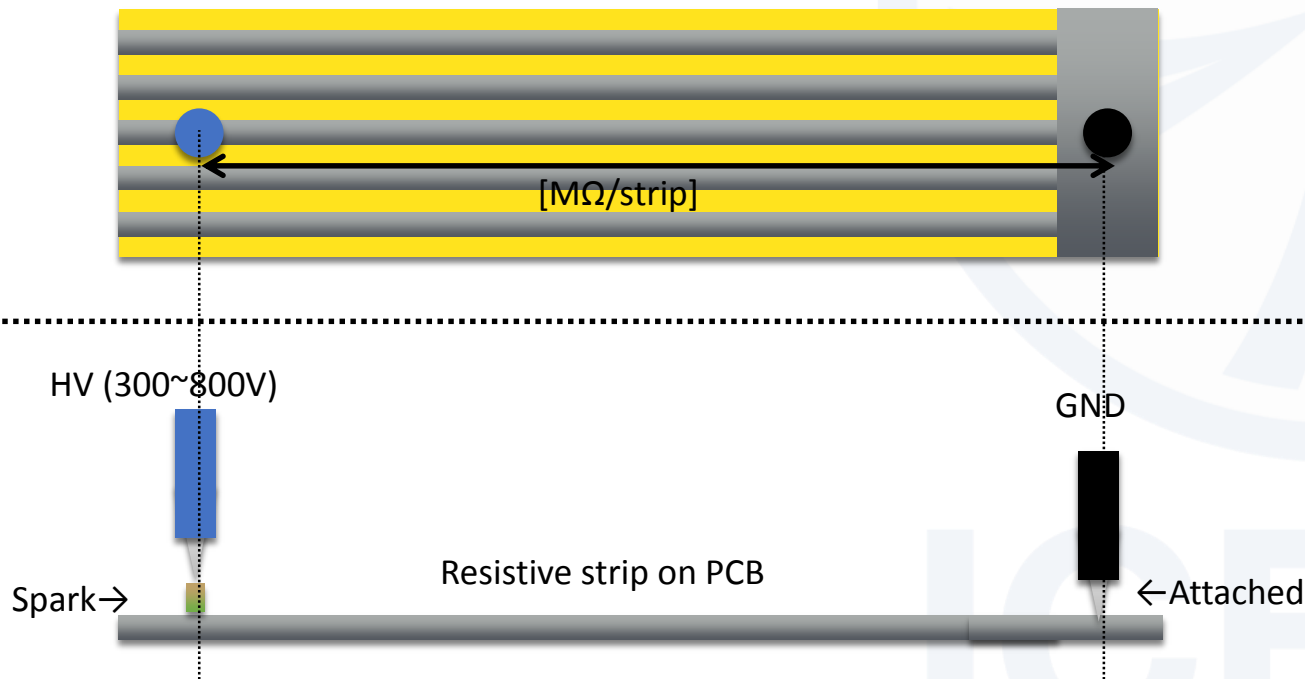
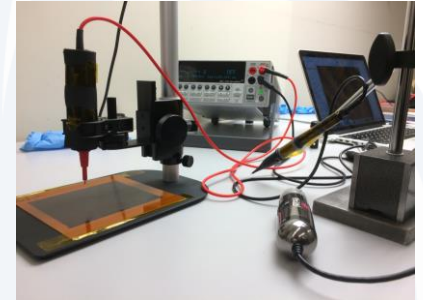


Masahiro Yamatani, Tatsuya Masubuchi
ICEPP, University of Tokyo

ICEPP
The University of Tokyo

Spark discharge test Setup

- * Keithley for voltage adding (300,500,800 V)
- * 2 probes connected to Resistive strips
 - One is attached on HV line side
 - Other one is on the strips (floating for spark)
- * Optional current limit (10uA, 100uA, ...)



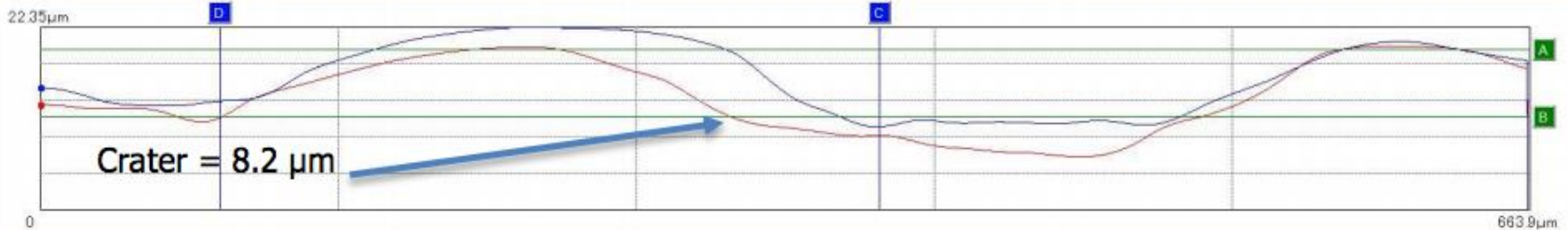
* **Checked resistivity/strip vs surface status by SEM**

Point : 5 Voltage : 300 V Resistance : 4.41 M Ω Current limit : 10 μ A



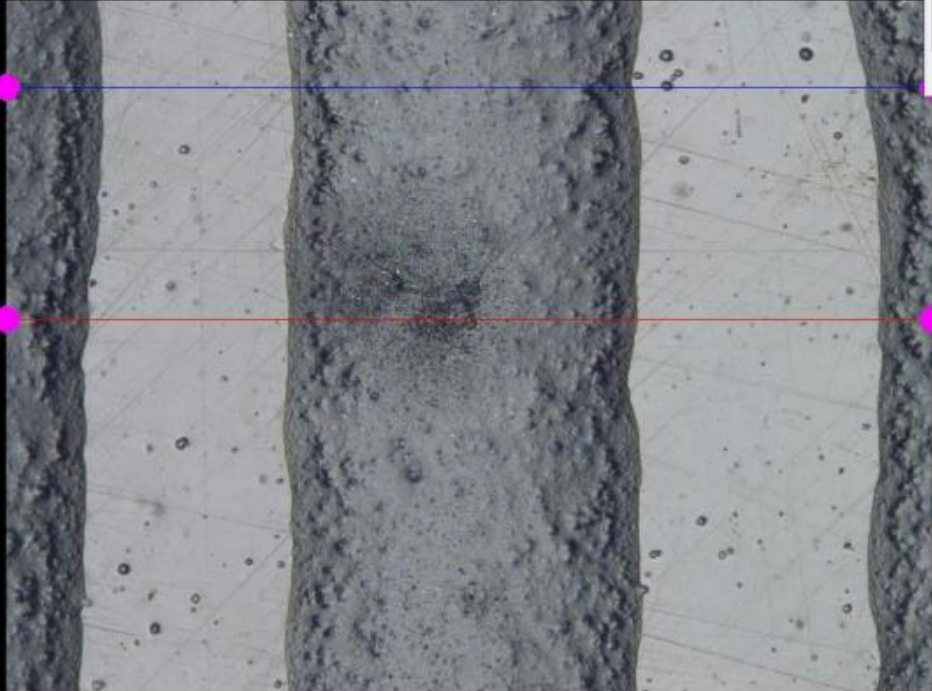
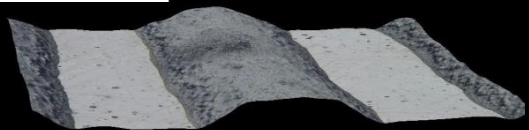
3D measurement	
Measure	Result
Height[A-B]	8.227 μ m
Width [C-D]	294.0 μ m
List >>	

Profile

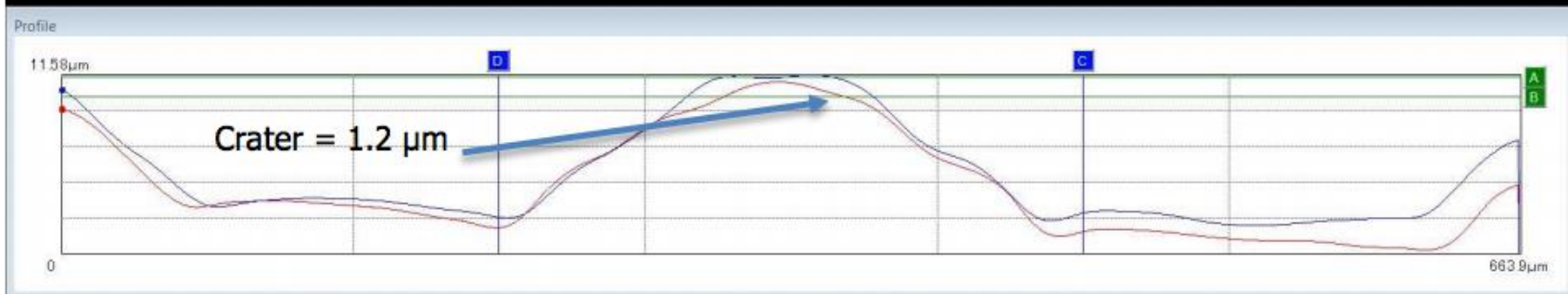


Point : 8 Voltage : **300 V** Resistance : **4.41 MΩ** Current limit : 10 μA

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3D measurement	
Measure	Result
Height [A-B]	1.272 μm
Width [C-D]	265.6 μm
List >>	



Point : 2 Voltage : 900 V Resistance : 4.41 MΩ Current limit : 10 μA

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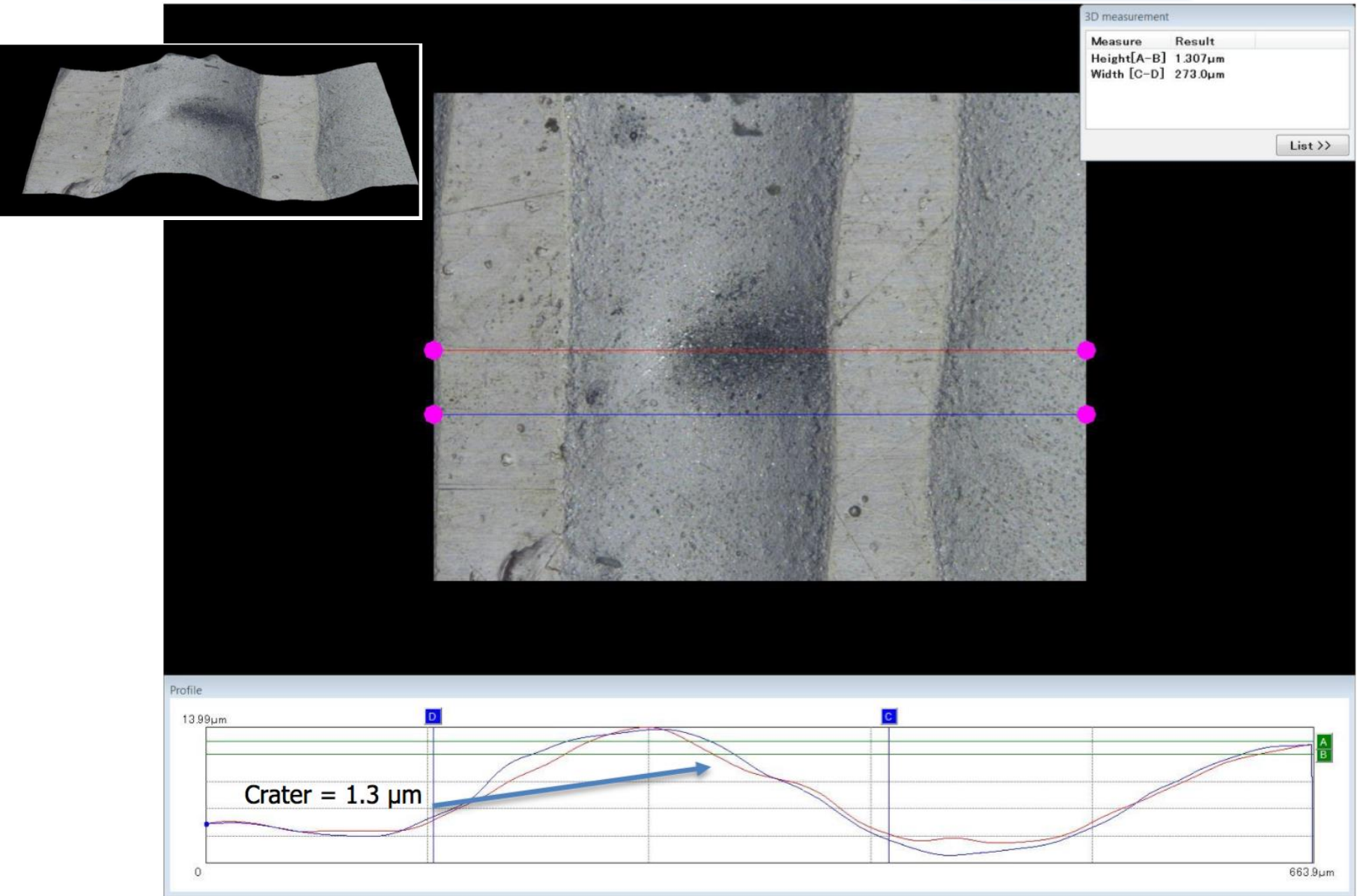


Table 5 – 3D profile of the spark discharge crater.

Point : 4 Voltage : 500 V Resistance : 1.3 M Ω Current limit : 10 μ A

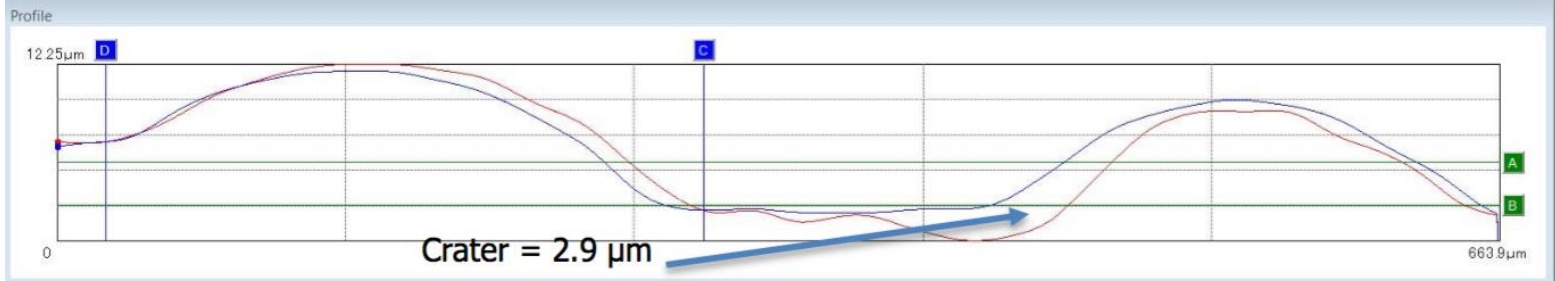
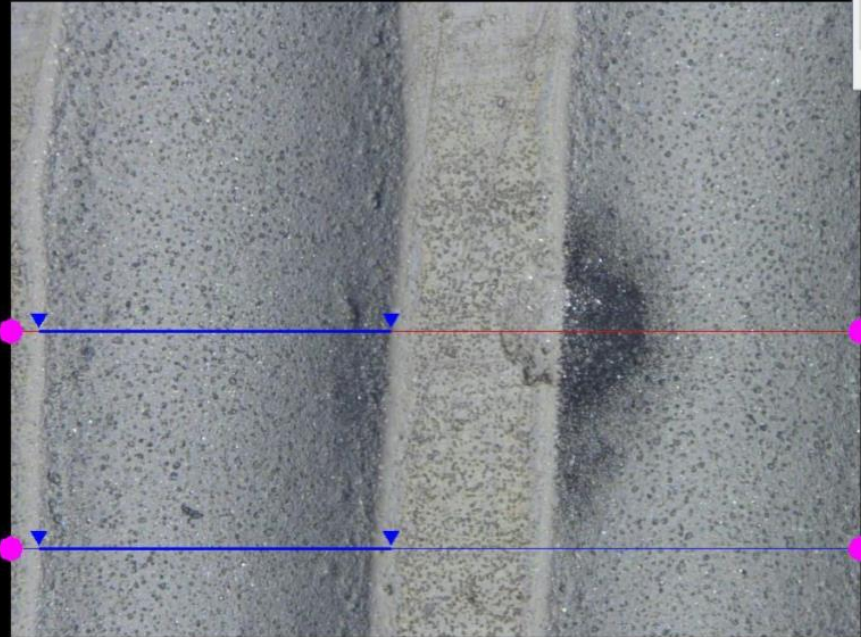
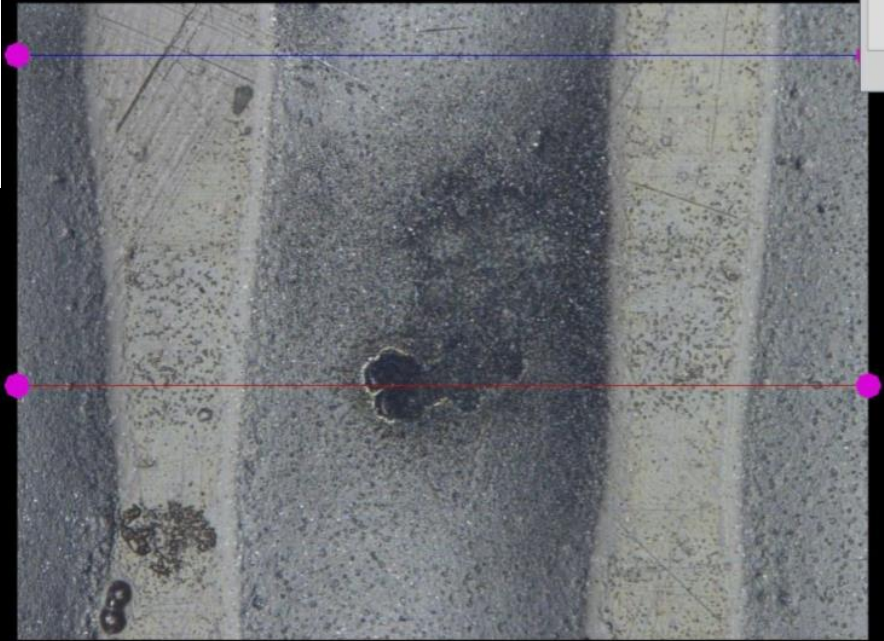
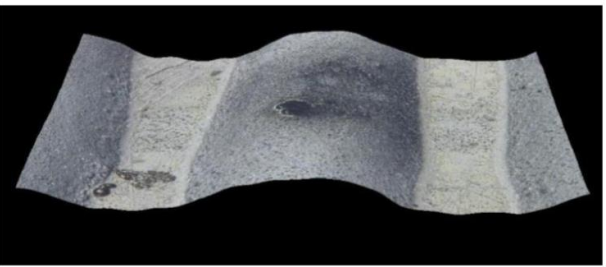


Table 7 – 3D profile of the spark discharge crater.

Point : 9 Voltage : 900 V Resistance : 0.9 M Ω Current limit : 100 μ A

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3D measurement	
Measure	Result
Height[A-B]	1051 μ m
Width [C-D]	275.2 μ m
List >>	

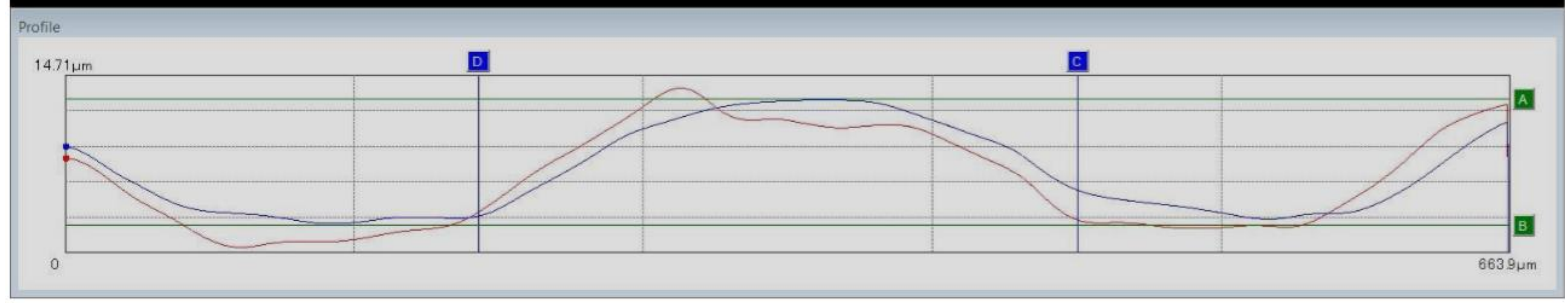
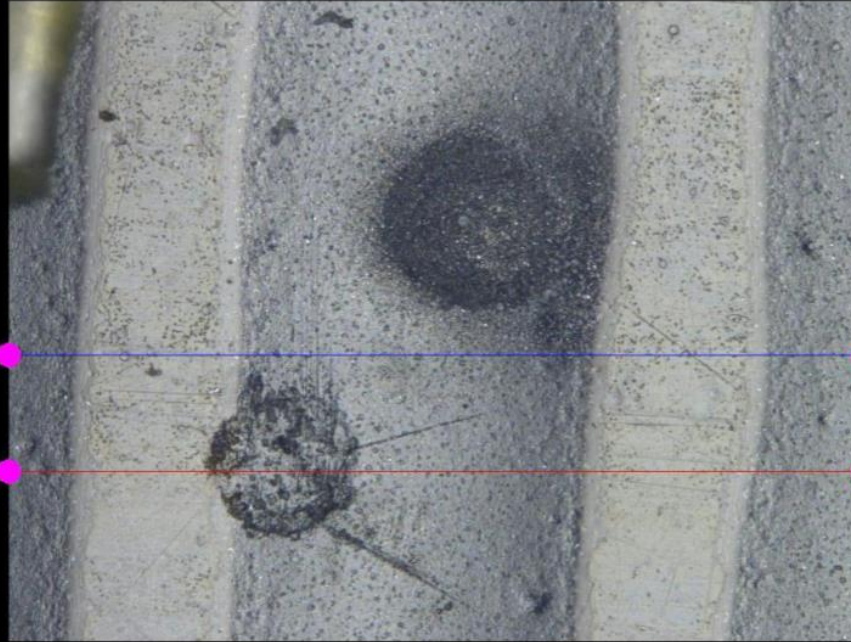
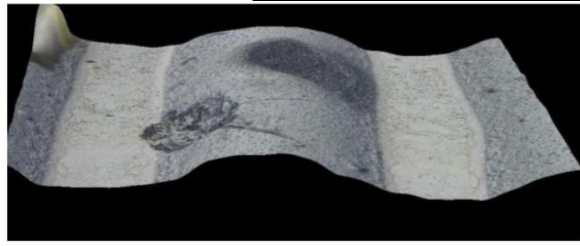


Table 13 – 3D profile of the spark discharge crater.

Point : 12 Voltage : 500 V Resistance : 1.2 M Ω Current limit : 100 μ A

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3D measurement	
Measure	Result
Height [A-B]	12.95 μ m
Width [C-D]	294.0 μ m
List >>	

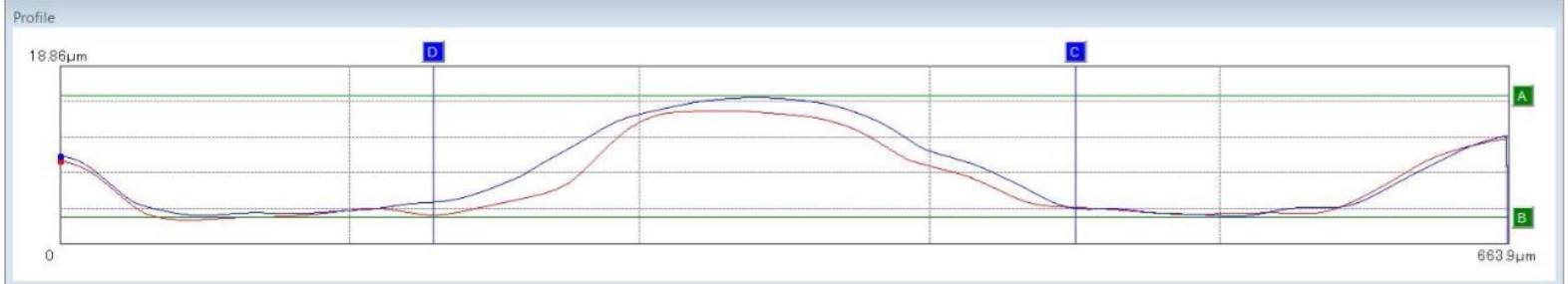


Table 20 – 3D profile of the spark discharge crater.

- Conclusion

Bulk technology

- 600mm x 600mm → metal or single resistive
- 10cm x 10cm → double resistive high rate

STD Micromegas

- 2m x 500mm → metal or single resistive

u-Rwell

- 1.3m x 0.5m → single resistive
- 10cm x 10cm → double resistive high rate